

In re Applicant:

Randy Skocypec et al.

Art Unit:

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Serial No.:

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Examiner:

Bibi Sharidan Carrillo

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For:

Cleaning Semiconductor

Wafers

Docket:

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Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

REPLY TO PAPER NO. 09072004

Sir:

In response to the office action mailed September 9, 2004, please amend the abovereferenced patent application as follows:

Date of Deposit: November 8, 2004

I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O., Box 1450, Alexandria, VA 22313-1450,

Cynthia(L/Hayden